

10/567344

INFOCRYPTO 06 FEB 2006

Application No. N/A

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant : Yoav Paltiel et al.
Appl. No. : N/A
Filed : 6 February 2006
Title : Method And Apparatus For Monitoring Labor Parameter

Group Art Unit: N/A
Examiner : N/A
Docket No. : 1312PAL-US
Honorable Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Kindly amend the above-identified application as follows: